

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention

[SILICON OXIDE GAP-FILLING PROCESS]

Application Number : 10/605478
Confirmation Number:
First Named Applicant: Hsiu-Chuan Chu
Attorney Docket Number: 12157-US-PA-X
Art Unit: 2824
Examiner: C. WILSON
Search string: (5872058 or 6030881 or 6335261).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
cw	1	5872058	1999-02-16	Van Cleemput; Patrick A.		438692	H01C71302
cw	2	6030881	2000-02-29	Papasouliotis; George D.		438424	H01L21762
cw	3	6335261	2002-01-01	Natzle; Wesley		438435	H01L2100

Signature

Examiner Name	Date
Christian Wilson	11/18/04